



DOCKET NO: VSEA 28-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Steven R. Walther et al.  
Serial No: 10/005,613  
Confirmation No: 9731  
Filed: October 26, 2001  
For: HYBRID SCANNING SYSTEM AND METHODS FOR ION  
IMPLANTATION  
Examiner: Rodney Glen McDonald  
Art Unit: 1753

**CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)**

The undersigned hereby certifies that this document is being placed in the United States mail with first-class postage attached, addressed to Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the 7 day of August, 2004.

  
Cheryl Purcell

**Mail Stop AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**Petition for Extension of Time**

A three-month extension of time to August 4, 2004 is requested for response to the Examiner's Final Office Action of February 4, 2004.

The extension fee of \$950.00 may be charged to deposit account No. 50-0896. If the amount is insufficient, please charge deposit account No. 50-0896. A duplicate of this Petition is enclosed.

Respectfully submitted,  
*Steven R. Walther et al., Applicants*

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By: 

Mark A. Superko, Reg. No. 34,027  
Varian Semiconductor Equipment  
Associates, Inc.  
35 Dory Rd.  
Gloucester, Massachusetts 01930-2297  
Telephone: (978) 282-5915

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